

Form 1449 (Modified) Information Disclosure Statement By Applicant (Use Several Sheets if Necessary)	Atty Docket No.	GENSP047
	Application No.:	10/762,680
	Applicant	Osamu KOBAYASHI
	Filing Date	01/21/04
	Group	2134
		Page 1 of 3

U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
	1.	6,049,316	04/11/00	Nolan et al.			06/12/97
	2.	2002/0061024	05/23/02	Malkemes et al.			11/15/01
	3.	2004/0203383	10/14/04	Kelton et al.			02/28/03
	4.	7,136,415	11/14/06	Yun et al.			11/12/02
	5.	7,295,578	11/13/07	Lyle et al.			09/12/01

Foreign Patent or Published Foreign Patent Application

Examiner Initial		Document No.	Publication Date	Country or Patent Office	Class	Sub-Class	Translation	
							Yes	No
	6.	EP 1 473 700	11/03/04	EP				
	7.	CN 1353513	06/12/02	CN				

Other Documents

Examiner Initial	No.	Author, Title, Place (e.g. Journal) of Publication, Date
	8.	Search Report dated July 2, 2008 in EP Application No. 08155263.0
	9.	Search Report dated June 30, 2008 in EP Application No. 08155262.2
	10.	Notice of Allowance dated October 1, 2008 in US Application No. 10/909,085
	11.	Office Action dated October 16, 2008 in US Application No. 10/909,027
	12.	Search Report dated July 21, 2008 from European Patent Application No. 08153724.3
	13.	Office Action dated July 4, 2008 from Chinese Patent Application No. 200410038545.8
	14.	Office Action dated May 23, 2008 from Chinese Patent Application No. 200410071498.7
	15.	Office Action dated August 8, 2008 from Chinese Patent Application No. 200410045686.2
	16.	Office Action dated August 8, 2008 from Chinese Patent Application No. 200410087460.9
	17.	VESA Display Port Standard, Version 1.1, March 19, 2007.
	18.	Office Action dated August 6, 2008 from U.S. Application No. 10/726,895
	19.	Office Action dated August 19, 2008 from U.S. Application No. 10/726,440
	20.	Office Action dated August 29, 2008 from U.S. Application No. 11/742,387

Examiner	Date Considered
-----------------	------------------------

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form 1449 (Modified) Information Disclosure Statement By Applicant (Use Several Sheets if Necessary)	Atty Docket No.	GENSP047
	Application No.:	10/762,680
	Applicant	Osamu KOBAYASHI
	Filing Date	01/21/04
	Group	2134
		Page 2 of 3

U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
	21.						

Foreign Patent or Published Foreign Patent Application

Examiner Initial		Document No.	Publication Date	Country or Patent Office	Class	Sub-Class	Translation	
							Yes	No
	22.							

Other Documents

Examiner Initial	No.	Author, Title, Place (e.g. Journal) of Publication, Date
	23.	Examination Report dated June 5, 2008 from European Patent Application No. 04252057.7
	24.	Examination Report dated June 5, 2008 from European Patent Application No. 04251581.7
	25.	Examination Report dated June 5, 2008 from European Patent Application No. 04252202.9
	26.	Examination Report dated June 5, 2008 from European Patent Application No. 04252056.9
	27.	Examination Report dated June 5, 2008 from European Patent Application No. 04252054.4
	28.	Examination Report dated June 5, 2008 from European Patent Application No. 04252203.7
	29.	Chinese Office Action dated June 27, 2008 from Chinese Patent Application No. 200410038432.8
	30.	Office Action dated June 27, 2008 from U.S. Application No. 10/909,085
	31.	Office Action dated August 1, 2008 in U.S. Application No. 10/909,027
	32.	Chinese Office Action dated June 27, 2008 in Chinese Application No. 200410038546.2
	33.	Office Action dated June 24, 2008 from U.S. Application No. 10/726,794
	34.	Search Report dated July 10, 2008 from European Patent Application No. 08153726.8
	35.	Office Action dated July 2, 2008 from European Patent Application No. 04252205.2
	36.	Kobayashi, "DisplayPort Technical Overview," http://web.archive.org/web/20060726222849/http://gnss.com/technology/DisplayPort+Technical+Overview+White+Paper.pdf , June 26, 2006.

Examiner	Date Considered
-----------------	------------------------

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form 1449 (Modified) Information Disclosure Statement By Applicant (Use Several Sheets if Necessary)	Atty Docket No.	GENSP047
	Application No.:	10/762,680
	Applicant	Osamu KOBAYASHI
	Filing Date	01/21/04
	Group	2134
		Page 3 of 3

U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
	37.						

Foreign Patent or Published Foreign Patent Application

Examiner Initial		Document No.	Publication Date	Country or Patent Office	Class	Sub-Class	<u>Translation</u>	
							Yes	No
	38.							

Other Documents

Examiner Initial	No.	Author, Title, Place (e.g. Journal) of Publication, Date
	39.	Office Action dated April 4, 2008 in CN Patent Application No. 200410043419.1
	40.	Office Action dated September 12, 2008 in CN Patent Application No. 200410044503.5
	41.	Office Action dated October 21, 2008 from U.S. Application No. 11/747,839
	42.	English Translation of Office Action dated October 31, 2008 from Chinese Patent Application No. 200410095171.3
	43.	
	44.	
	45.	
	46.	
	47.	
	48.	
	49.	
	50.	
	51.	
	52.	

Examiner	Date Considered
-----------------	------------------------

Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.